



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 24, 2025

IGI Report Number

LG751517031

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements

10.29 X 7.25 X 4.81 MM

GRADING RESULTS

Carat Weight

3.09 CARATS

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

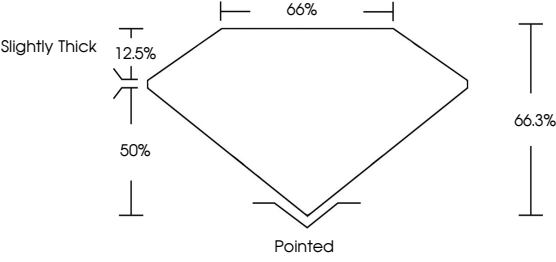
Inscription(s)

 LG751517031

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

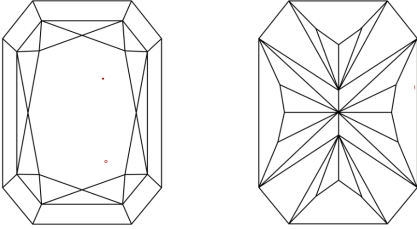
PROPORTIONS



Slightly Thick

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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10.29 X 7.25 X 4.81 MM

Carat Weight

3.09 CARATS

Color Grade

E

Clarity Grade

VS 1

Depth

66.3%

Table

65%

Girdle

Slightly Thick

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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